## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of		) PATENT APPLICATION
Inventor:	Tingkai Li, Sheng Teng Hsu, and Bruce D. Ulrich	) April 1, 2008
Serial No.:	10/780,919	) ATTORNEY DOCKET ) No. SLA0772
Filed:	February 17, 2004	) Group Art Unit: 1792
Title:	MOCVD PGO THIN FILMS DEPOSITED ON INDIUM OXIDE FOR FERAM APPLICATIONS	) Examiner: Brian K. ) Talbot ) Confirmation No. 1905 )
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## RESPONSE UNDER 37 C.F.R. §1.111

Mail Stop Fee Amendment Hon. Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This amendment responds to an Office Action dated December 6, 2007 in the above-identified patent application.

There are no changes to the specification herein.

Changes to the claims begin on page 2.

Remarks begin on page 5.

Two 1-page USPTO assignment records follow the Remarks.

A Terminal Disclaimer is attached.